PTO/SB/50 (2/98) Approved for use through 09/30/2000. OMB 0651-0033 Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

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REISSUE PATENT APPLICATION TRANSMITTAL

Address to:

Assistant Commissioner for Patents Box Patent Application Washington, DC 20231

Attorney Docket No.

2001-0386

First Named Inventor

Masayoshi HIROSE

et al.

Original Patent Number

5,888,126

Original Patent Issue Date March 30, 1999 (Month/Day/Year)

Express Mail Label No.

APPLICATION FOR REISSUE OF:

(check applicable box) [X] Utility Patent

[] Design Patent

[] Plant Patent

APPLICATION ELEMENTS

- 1. [X] Fee Transmittal Form (PTO/SB/56) (Submit an original, and a cuplicate for fee processing)
- 2. [X] Specification and Claims (amended, if appropriate)
- 3. [X] Drawing(s) (proposed amendments, if appropriate)
- 4. [X] Reissue Oath / Declaration (Unexecuted) (original or copy) (37 CFR 1.175)(PTO/SB/51 or 52)
- 5. Original U.S. Patent
 - [X] Offer to Surrender Original Patent (37 CFR 1.178) (PTO/SB/53 or PTO/SB/54)

or

- Ribboned Original Patent Grant 1
- Affidavit/Declaration of Loss (PTO/SB/55) []
- 6. Original U.S. Patent currently assigned? [X] Yes [] No

(If Yes, check applicable box(es)

[X] Written Consent of all Assignees (Unexecuted) (PTO/SB/53 or 54)

- 37 CFR 3.73(b) Statement
- Power of Attorney

- **ACCOMPANYING APPLICATION PARTS** 7. [] Foreign Priority Claim (35 USC 119)
- (if applicable)
- Information Disclosure Statement (IDS)/PTO-1449
 - [] Copies of IDS Citations
- English Translation of Reissue Oath/Declaration (if applicable)
- 10. [] Small Entity Statement
 - [] Statement filed in prior application Status Still proper and desired
- 11. [] Preliminary Amendment
- 12. [X] Return Receipt Postcard (MPEP 503) (Should be specifically itemized)
- 13. [X] Other Status of Claims and Support for Claim Changes under 37 CFR 1.173(c)

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT **ACCOUNT NO. 23-0975**

15. CORRESPONDENCE ADDRESS



000513

PATENT TRADEMARK OFFICE 2033 "K" Street, Suite 800 Washington, D.C. 20006 Phone: (202) 721-8200 Fax:(202) 721-8250

11. SIGNATURE OF APPLICANT, ATTORNEY OR AGENT REQUIRED		
NAME	Nils E. Pedersen Reg. No. 33,145	
SIGNATURE	1190/William	
DATE	March 30, 2001	

Attn: BOX REISSUE

Issued March 30, 1999

Masayoshi HIROSE et al.

Attorney Docket No. 2001-0386

Serial No. NEW

Filed March 30, 2001

POLISHING APPARATUS INCLUDING TURNTABLE WITH POLISHING SURFACE OF DIFFERENT HEIGHTS

PATENT OFFICE FEE TRANSMITTAL FORM

Assistant Commissioner for Patents, Washington, DC 20231

Sir:

Attached hereto is a check in the amount of \$1378.00 to cover Patent Office fees relating to filing the following attached papers:

Additional Claims Fee:

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Respectfully submitted.

Masayoshi HIROSH et al.

Nils E. Pedersen

Registration No. 33,145 Attorney for Applicants

NEP/krl WENDEROTH, LIND & PONACK, L.L.P. 2033 K St., N.W., Suite 800 Washington, D.C. 20006-1021 Telephone (202) 721-8200 March 30, 2001

1Check No. 43751

2001 0386

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In re reissue application of

U.S. Patent No. 5,888,126

ATTN: BOX REISSUE

Issued March 30, 1999

Docket No. 2001-0386

Masayoshi HIROSE et al.

Serial No. NEW

Filed March 30, 2001

POLISHING APPARATUS INCLUDING TURNTABLE WITH POLISHING SURFACE OF DIFFERENT HEIGHTS

OFFER TO SURRENDER ORIGINAL PATENT

Assistant Commissioner for Patents, Washington, D.C.

Sir:

Applicants hereby offer to surrender the original patent. The original patent, or if the original patent is lost or inaccessible, an Affidavit or Declaration to that effect, will be submitted upon request by the Office.

Respectfully submitted,

Masayoshi HIRO

Ву

Mils E. Pedersen

Registration No. 33,145 Attorney for Applicants

NEP/krl

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Telephone (202) 721-8200

March 30, 2001

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ACCOUNT NO. 23-0975

In re reissue application of	:	
U.S. Patent No. 5,888,126	:	ATTN: BOX REISSUE
Issued March 30, 1999	:	Docket No. 2001-0386
Masayoshi HIROSE et al.	:	
Serial No. NEW	:	

POLISHING APPARATUS INCLUDING TURNTABLE WITH POLISHING SURFACE

OF DIFFERENT HEIGHTS

Filed March 30, 2001

CONSENT TO ASSIGNEE

Assistant Commissioner for Patents, Washington, D.C.

Sir:

Ebara Corporation, Assignee of U.S. Patent 5,888,126, hereby consents to the filing of the present application for the reissue of the U.S. patent.

Ownership of U.S. Patent No. 5,888,126 by Ebara Corporation is established by an Assignment recorded in the Office at reel 7985, frame 0679-0682.

Respectfully submitted,

Ebara Corporation

By:	(signature)
Name:	(typed)
Title:	(typed)

In re reissue application of

U.S. Patent No. 5,888,126

ATTN: BOX REISSUE

Issued March 30, 1999

Docket No. 2001-0386

Masayoshi HIROSE et al.

Serial No. NEW

Filed March 30, 2001

POLISHING APPARATUS INCLUDING TURNTABLE WITH POLISHING SURFACE OF DIFFERENT HEIGHTS

STATUS OF CLAIMS AND SUPPORT FOR CLAIM CHANGES, 37 CFR 1.173(c)

Assistant Commissioner for Patents, Washington, D.C.

Sir:

Pursuant to the above-referenced reissue application, the status of the claims and the support for the claim changes is hereby presented.

Claims 1-26 are pending. Of such claims, claims 1-21 are unamended. Claims 22-26 are added.

An explanation for the support in the disclosure for the subject matter of claims 22-26 is as follows:

The specification as a whole is directed to a polishing apparatus for polishing a semiconductor wafer to a flat mirror finish, as discussed in the Field of the Invention. The more specific limitations of claim 22 are supported by, for example, the discussion of the top ring beginning at line 35 of column 5. The abrasive cloth is discussed beginning at the line 42 of column 5. Also note the discussion beginning at line 57 of column 5. The specification as a whole discusses the plurality of portions of the abrasive cloth that are individually and

independently pressed against the wafer. Employing air pressure to do so is specifically discussed in column 11 beginning at line 15. This same section can be found to support the limitations of dependent claims 23 through 25.

The method claim of independent method claim 26 is also supported by the same portions as discussed above.

Respectfully submitted,

Masayoshi HIROSE et al-

Nils E. Pedersen

Registration No. 33,145 Attorney for Applicants

NEP/krl Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 March 30, 2001

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